## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA et al.

Application No.: New U.S. National Stage of PCT/JP2004/018435

Filed: June 1, 2006 Docket No.: 128253

For: EXPOSURE APPARATUS, EXPOSURE METHOD, METHOD FOR PRODUCING

DEVICE, AND OPTICAL PART

## PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.